



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Lucius M. Sherwin  
Serial No.: 09/921,364  
Filing Date: 08/02/2001  
Customer No.: 23494

Art Unit: 2877  
Examiner: Brown, K.  
Docket No.: TI-30661  
Conf. No.: 6223

Title: A PARTICLE DETECTION AND REMOVAL APPARATUS FOR USE ON WAFER FABRICATION EQUIPMENT TO LOWER TOOL RELATED DEFECTS FROM PARTICLE CONTAMINATION

**SUPPLEMENTAL DECLARATION**

Commissioner of Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

I, Lucius M. Sherwin, as sole inventor named in the application for letters patent for an improvement in, Serial No. 09/921,364, filed in the United States Patent and Trademark Office on or about the 2nd day of August, 2001, declare that I have reviewed and understand the subject matter of the following amendment(s):

Amendment 1.111 filed 1/7/2004

that said subject matter, including the claims as amended, was part of our invention, and was invented before the filing of the original application, above identified, for such invention; and that I acknowledge my duty to disclose information of which I am aware which is material to the patentability of this application in accordance with Title 37, Code of Federal Regulations, §1.56.

I further declare that all statements herein made of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

SIGNATURE OF INVENTOR		
Lucius M. Sherwin	<i>Lucius M. Sherwin</i>	
DATE	<i>June 1, 2004</i>	